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Burn-in & Test Strategies Workshop

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March 15-18, 2015

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Valts Treibergs Session Chair **BiTS Workshop 2015 Schedule** 

**Frontiers Day** 

Monday March 16 4:30 pm

#### Wafer Level Pots of Gold

"Coplanarity Analysis of WLCSP Spring Probe Head"

Jiachun (Frank) Zhou , Daniel DelVecchio , & Cody Jacob - Smiths Connectors

#### "Pushing the envelope in DFM (Design for Manufacturing) for 0.2 mm Pitch WLCSP Socket"

Paul Gunn, Muhammad Syafiq, & Takuto Yoshida - Test Tooling Solutions Group

#### "Space Transformer PCB For Testing 200 µm WLCSP"

Khaled Elmadbouly - Smiths Connectors



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# Coplanarity Analysis of WLCSP Spring Probe Head

# Dr. Jiachun Zhou (Frank) Daniel DelVecchio, Cody Jacob Smiths Connectors



2015 BiTS Workshop March 15 - 18, 2015



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Wafer Level Pots of Gold - Wafer Level Chip Scale Packaging (WLCSP)

### Contents

- What learned from spring probe head applications in WLCSP testing
- Spring probe head structure examples
- Probe head coplanarity analysis methods
- Coplanarity analysis & example
- Probe head bowing & FEA
- Coplanarity vs. material & structure
- Summary





Coplanarity Analysis of WLCSP Spring Probe Head

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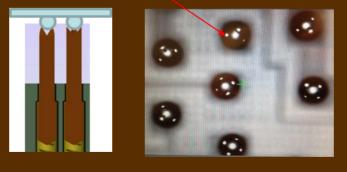
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# What Learned from WLCSP Testing

# **Spring Probe Head advantages**

- Highly compliant
- Reliable contact to balls
- High contact force ensures low C-Res
- Simplified field serviceability
- Easy handling





**Contact marks** 



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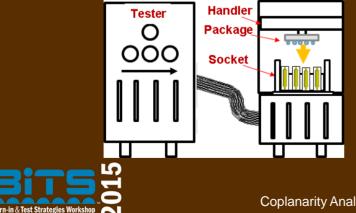
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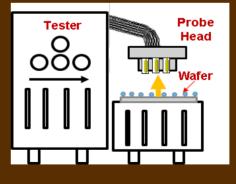
# What Learned from WLCSP Testing WLCSP Testing vs. Package Testing

- Set up: handling method; optical alignment in X-Y position
- Ball size: smaller in WLCSP
- Compliance: smaller to avoid penetrate ball and damage wafer
- Tip Coplanarity: very tight control on 1<sup>st</sup> touch to last touch
- Force: less force in WLCSP testing
- Contamination control

Package Testing



Wafer (WLCSP) Testing



Coplanarity Analysis of WLCSP Spring Probe Head

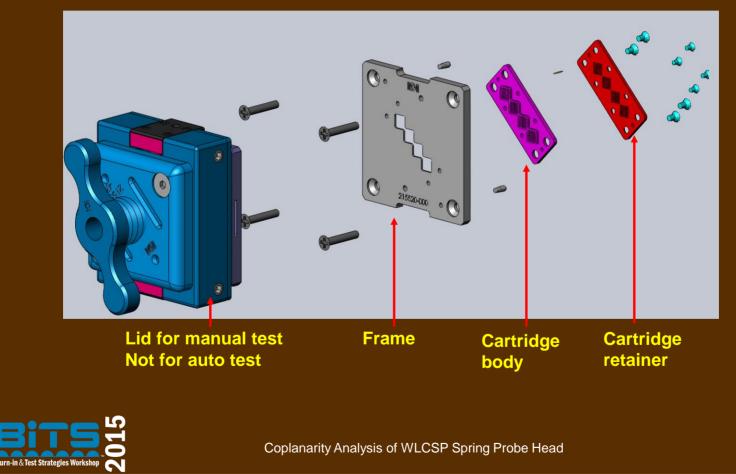
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# Spring Probe Head Example (400um)



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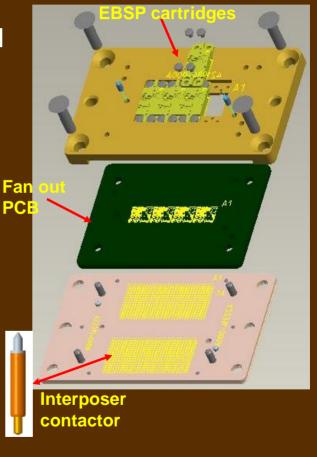
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# Spring Probe Head Example (200um)

- New contactor with Embedded Barrel Spring Probe (EBSP) developed for testing wafer, WLCSP, MicroCSP
- Components:
  - EBSP cartridge
  - Fan out PCB
  - Bottom contactor (spring probe, 0.8~1.0mm pitch)



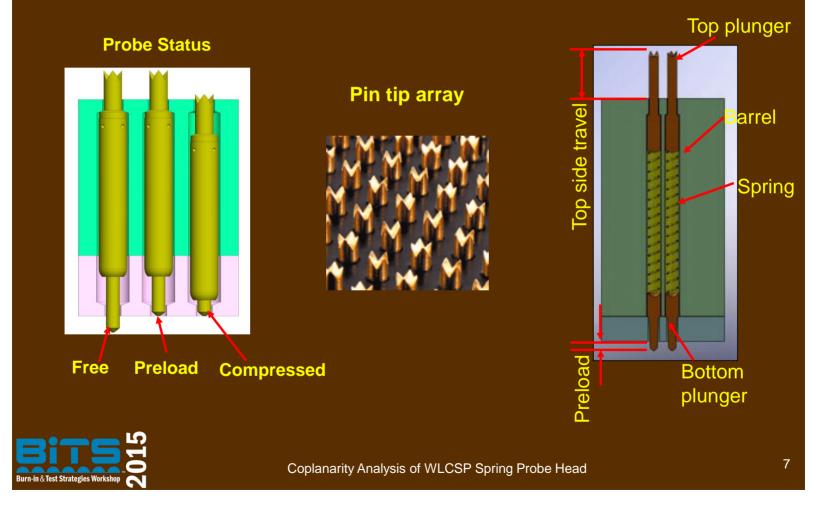


Coplanarity Analysis of WLCSP Spring Probe Head

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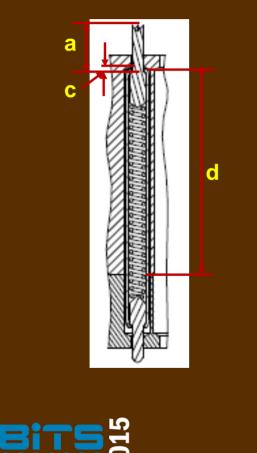
## **Spring Probe & Cavity Example**



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# Probe Head Coplanarity Analysis (worst case scenery)



• Coplanarity of spring probe tip array is determined by following formula:

# $\mathbf{H} = \Delta \mathbf{a} + \Delta \mathbf{c} + \Delta \mathbf{d} + \mathbf{\delta}$

• Where:

H – tip coplanarity of whole probe array  $\Delta a$  – top plunger neck tolerance, ~ +/- 0.02mm

 $\Delta c$  – barrel crimping thickness tolerance, negligible

 $\Delta d$  – counter bore depth tolerance, ~ +/- 0.025mm

 $\delta$  – cartridge bowing due to preload

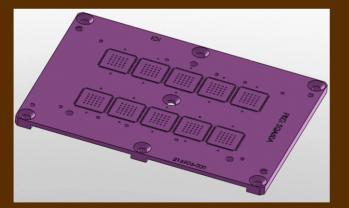
Coplanarity Analysis of WLCSP Spring Probe Head

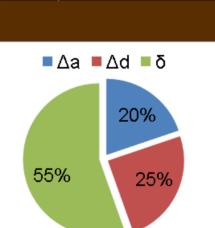
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#### **Coplanarity Analysis Example**

- Coplanarity of a 10-site WLCSP probe head was analyzed.
- The results show cartridge bowing contributes about 50% of total coplanarity.







Coplanarity Analysis of WLCSP Spring Probe Head

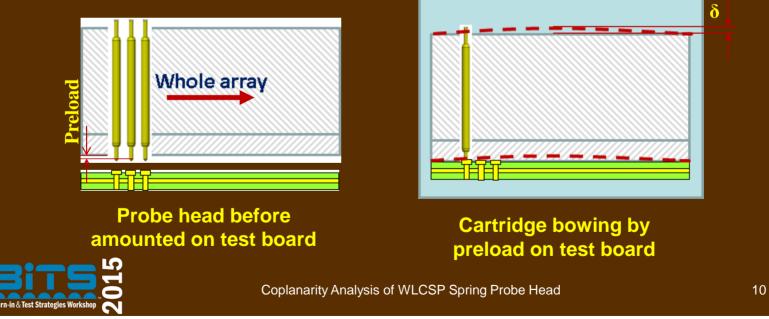
ltem	Coplanarity, um	
Δa	40	
Δd	50	
δ	112	
Н	202	

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# **Cartridge Bowing by Preload**

- To achieve low and stable Cres of spring probe, bottom plunger of probe is compressed when probe head is mounted on test board
- Cartridge is bent slightly due to spring force by spring probe, "δ"
- The "δ" is determined by total probe force, probe head design and materials



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### **Material Stiffness & Bowing**

- Spring probe preload & bowing
  - ~ 12gf
  - 20~30% of total spring compliance
  - Bowing: ~ 50% of total tip co-planarity variation
  - Less bowing with higher stiffness material (flexural modulus of elasticity)

Material		Flexural Modulus		
		English, kPSI	SI, Gpa	
А	Ceramic Filled PEEK	650	4.482	
В	MDS 100	1420	9.791	
С	New Thermoplastic Material	2465	17	
D	New Ceramic material	18853	130	



Coplanarity Analysis of WLCSP Spring Probe Head

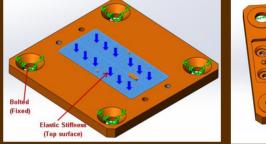
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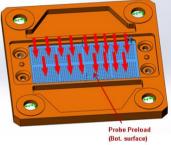
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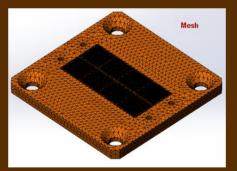
# **Bowing FEA - Example**

#### • FEA model & PH dimensions

# of sites	8	
Pitch, mm	0.4	
Pin count, per site	137	
Pin count, total	1096	
Preload/pin, gf	12	
Total preload, kgf	13.15	







#### FEA Model & Boundary conditions



Coplanarity Analysis of WLCSP Spring Probe Head

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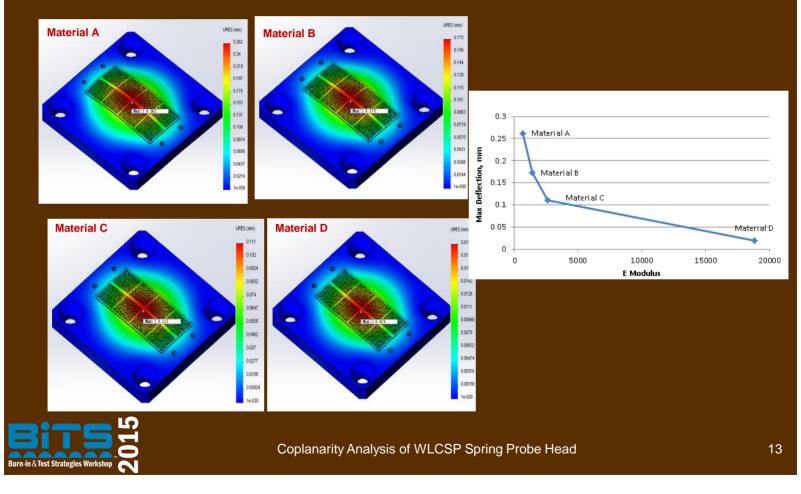
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# **Bowing FEA - Example**

• FEA results for 4 different materials.

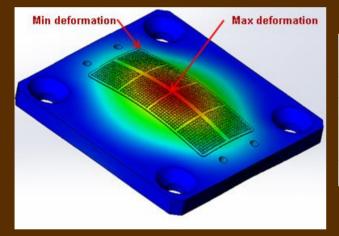


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# **Bowing & Coplanarity**

• Tip co-planarity = Max deflection – Min deflection



Material		PH Bowing, mm		Co-Planarity
		Max	Min	mm
Α	Ceramic Filled PEEK	0.261	0.054	0.207
В	MDS 100	0.172	0.033	0.139
С	New Thermoplastic Material	0.110	0.020	0.090
D	New Ceramic m <b>aterial</b>	0.019	0.016	0.003



Coplanarity Analysis of WLCSP Spring Probe Head

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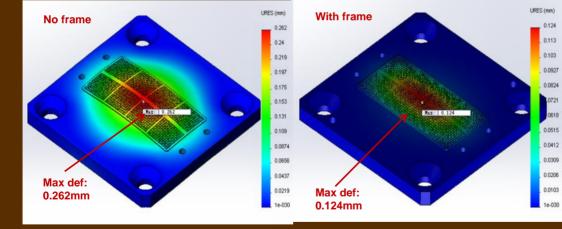
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#### **Coplanarity & Probe Head Structures**

- Carrier & frame structure
  - High stiffness frame to reduce bowing
  - Mostly stainless steel used for frame





Coplanarity Analysis of WLCSP Spring Probe Head

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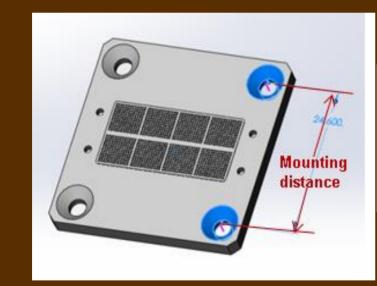
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# **Coplanarity & Probe Head Structures**

- Mounting structure
  - Less bowing with mounting screws closer to pin array
  - Limitation by electronic components or other features on test board



Mount Distance, mm	Max Deflection, mm	
44.6	0.329	
39.6	0.317	
34.6	0.301	
24.6	0.262	



Coplanarity Analysis of WLCSP Spring Probe Head

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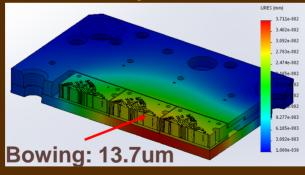
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# **Optimal Structures for Coplanarity**

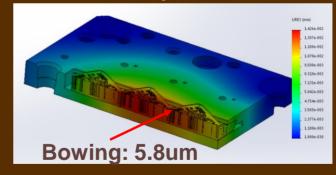
- Optimize structure to improve coplanarity.
  - Before optimization, 13.7um bowing
  - With optimal structure, 5.8um bowing



#### **Before Optimization**



#### **After Optimization**





Coplanarity Analysis of WLCSP Spring Probe Head

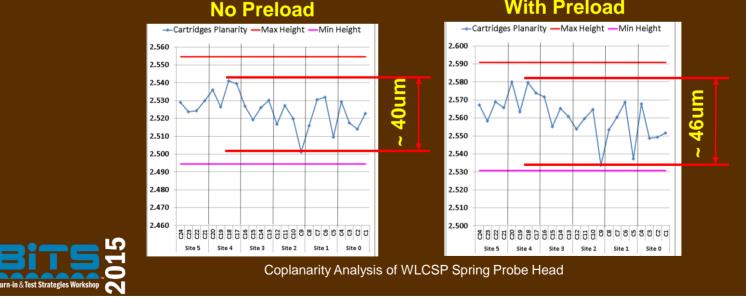
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# **Coplanarity Example**

- Coplanarity example with optimal structure and existing 0 manufacture capability as results below:
  - Six cartridges with SS frame, 200um pitch, ~ 400 pin/site
  - Cartridges surface coplanarity: no preload, ~ 40um; With preload, ~ 46um.
  - Preload contribution: only 6um, mainly by optimal structure.



With Preload

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# Summary

- Spring pin preload in WLCSP probe head impacts contactor tip co-planarity significantly.
- Higher stiffness material of PH is preferred to reduce bowing for better co-planarity.
- Optimal mechanical structure of PH can reduce bowing and improve co-planarity.
- With optimal structure and material, spring preload contribution to coplanarity can be reduced significantly to meet spec of wafer/WLCSP testing.



Coplanarity Analysis of WLCSP Spring Probe Head

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